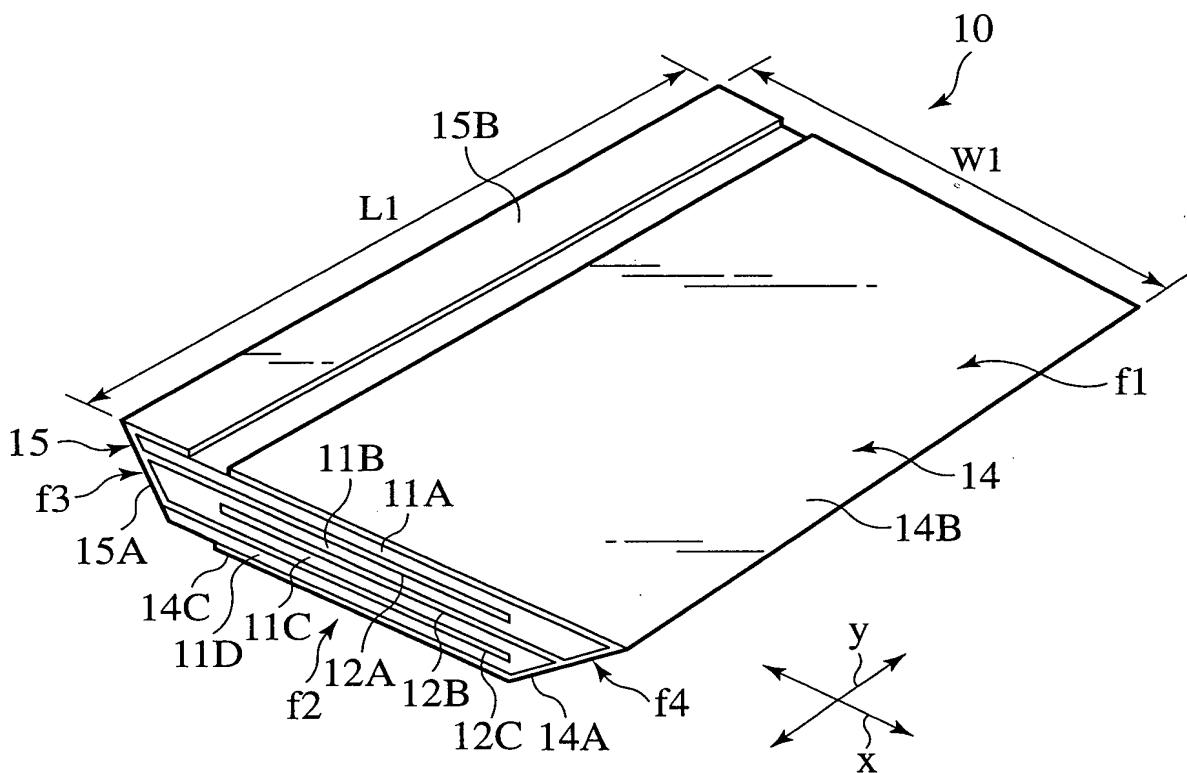


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FIG.1



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FIG.2

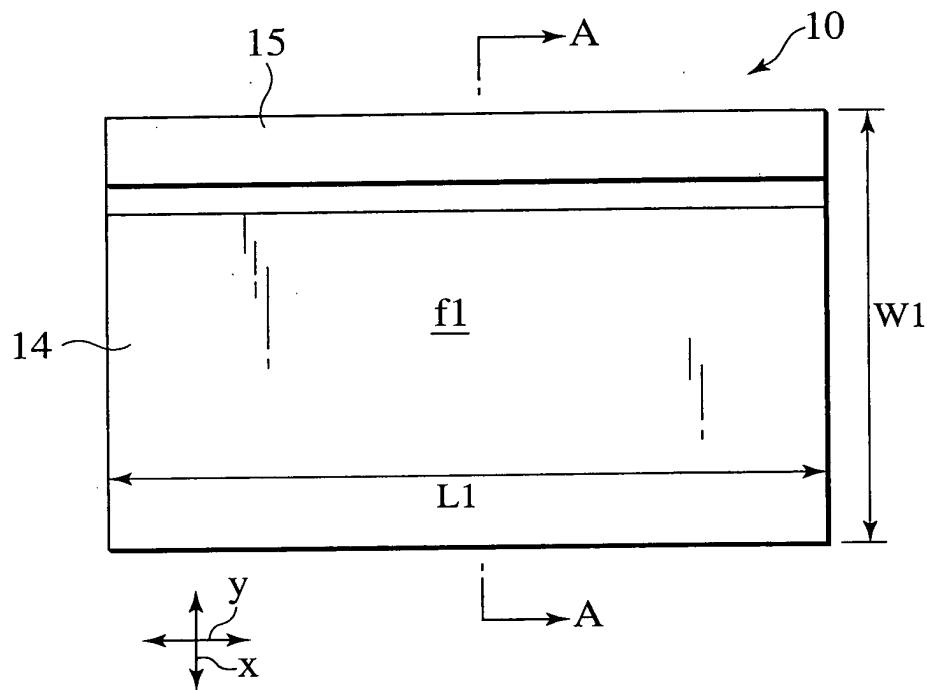
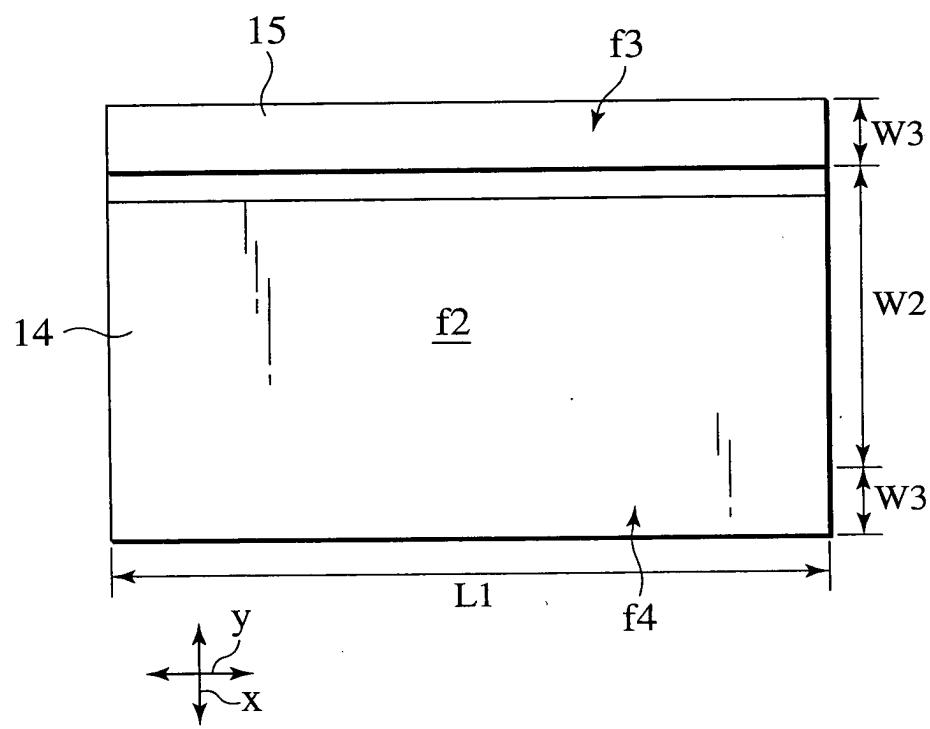
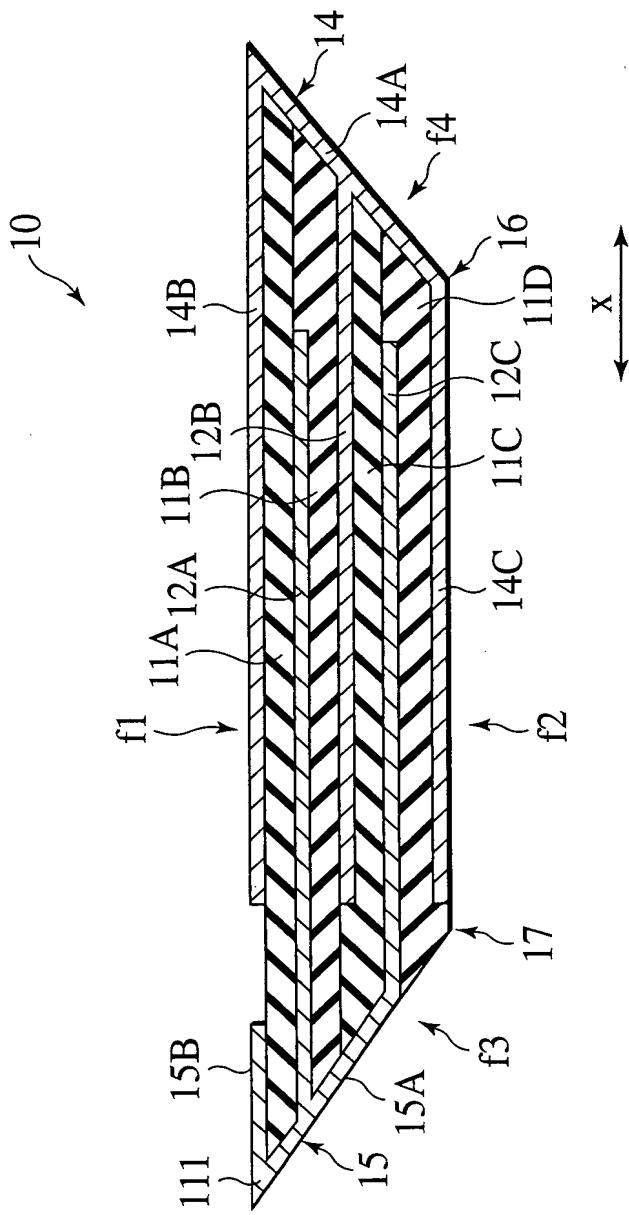


FIG.3



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FIG.4



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FIG.5

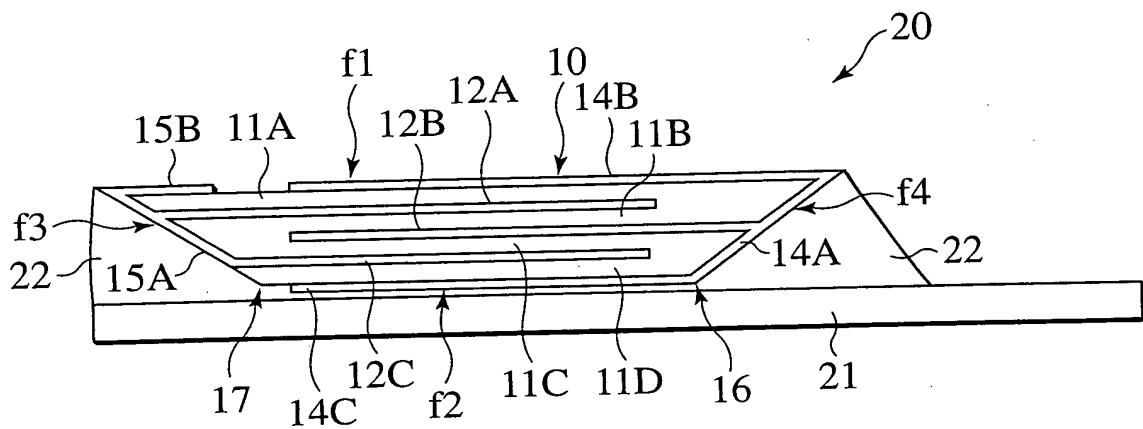
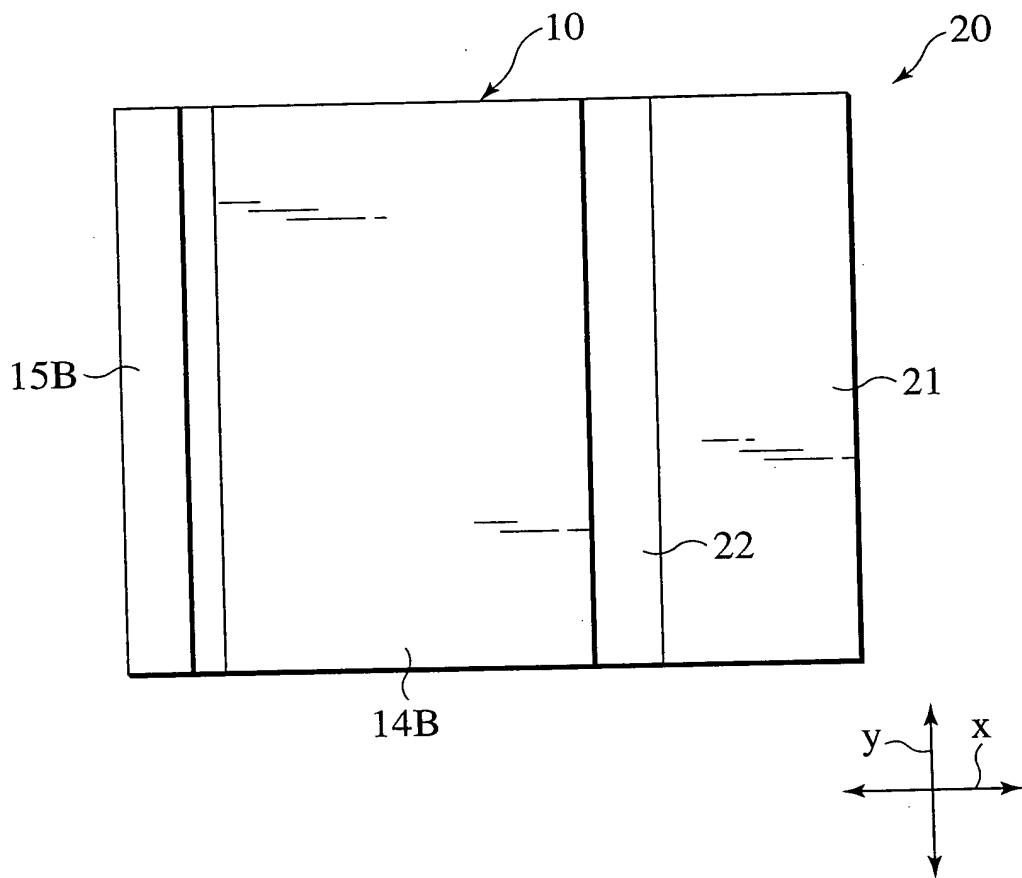


FIG.6



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FIG.7

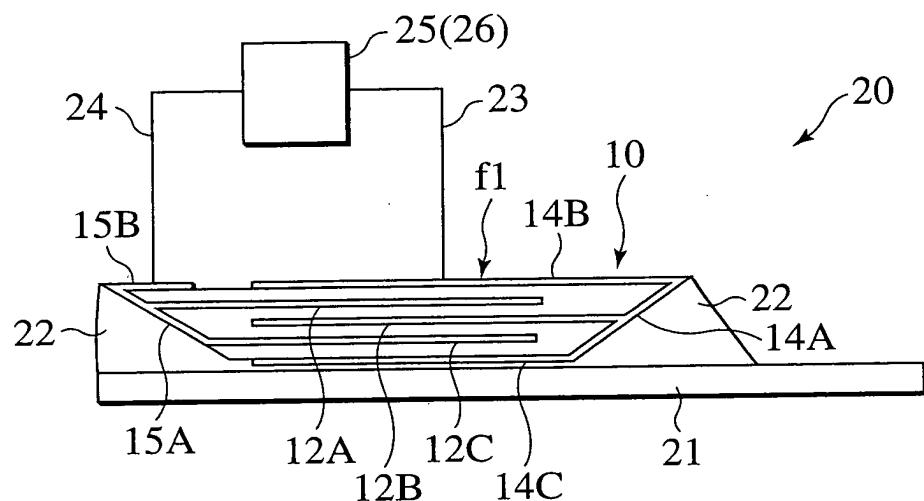
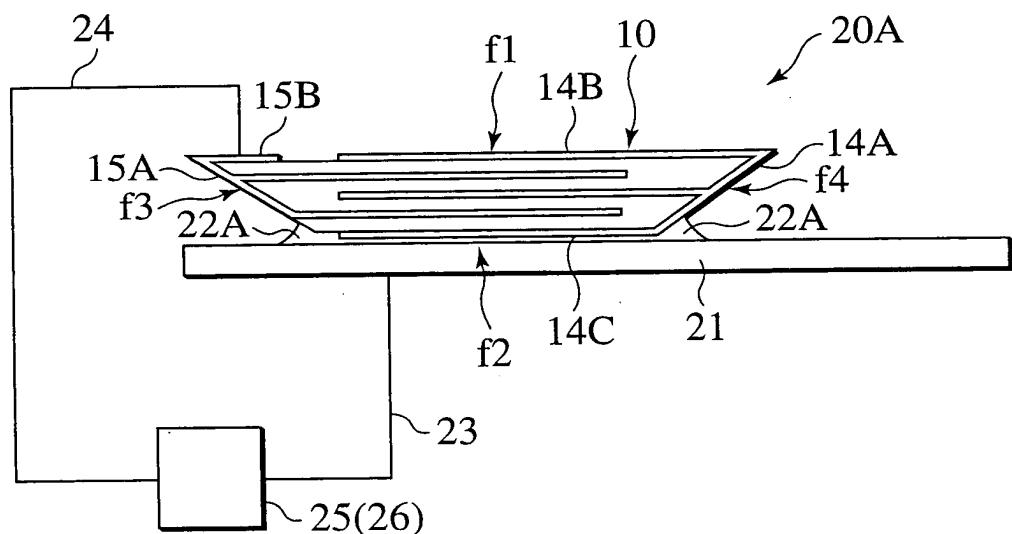
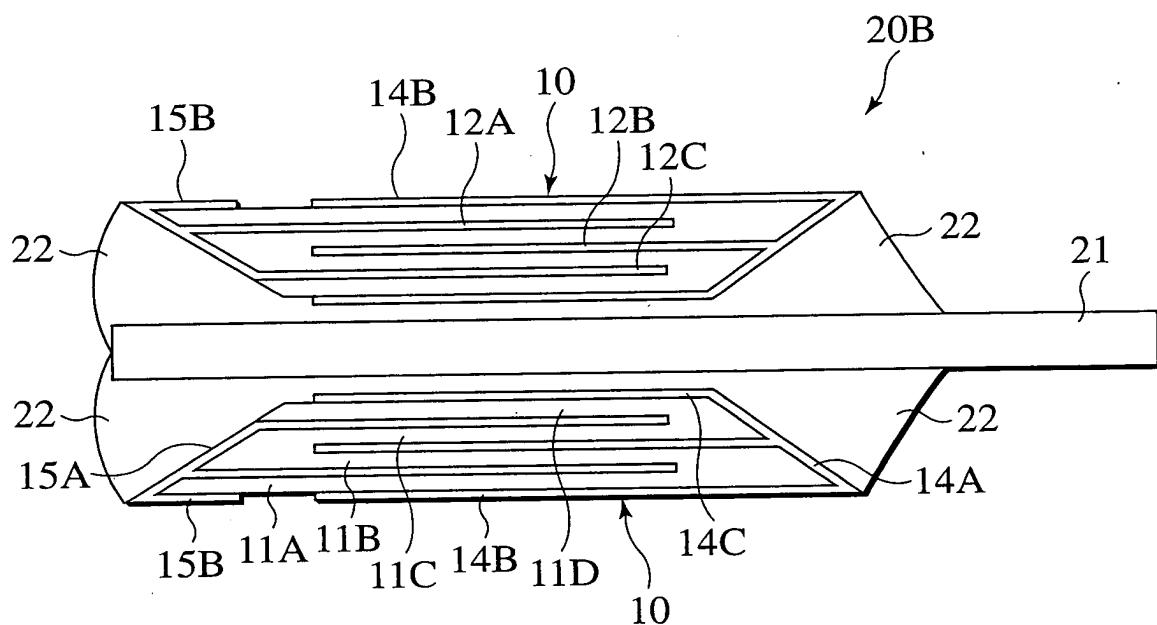


FIG.8



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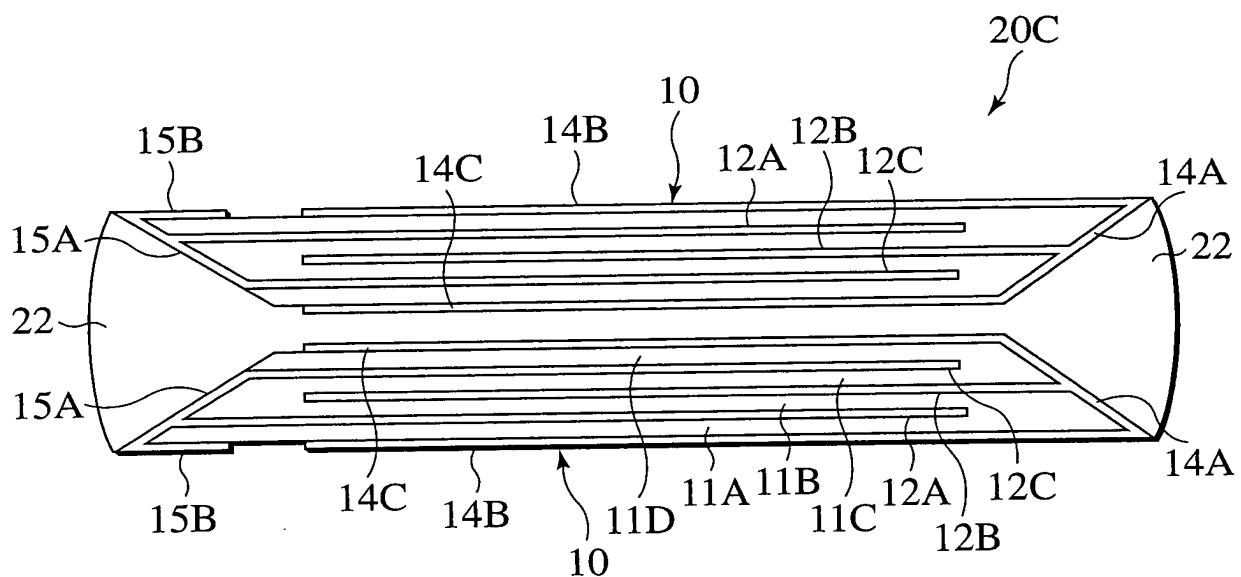
FIG.9



Applicant(s): Maki NAMERIKAWA, Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
Our Docket No.: 815_001

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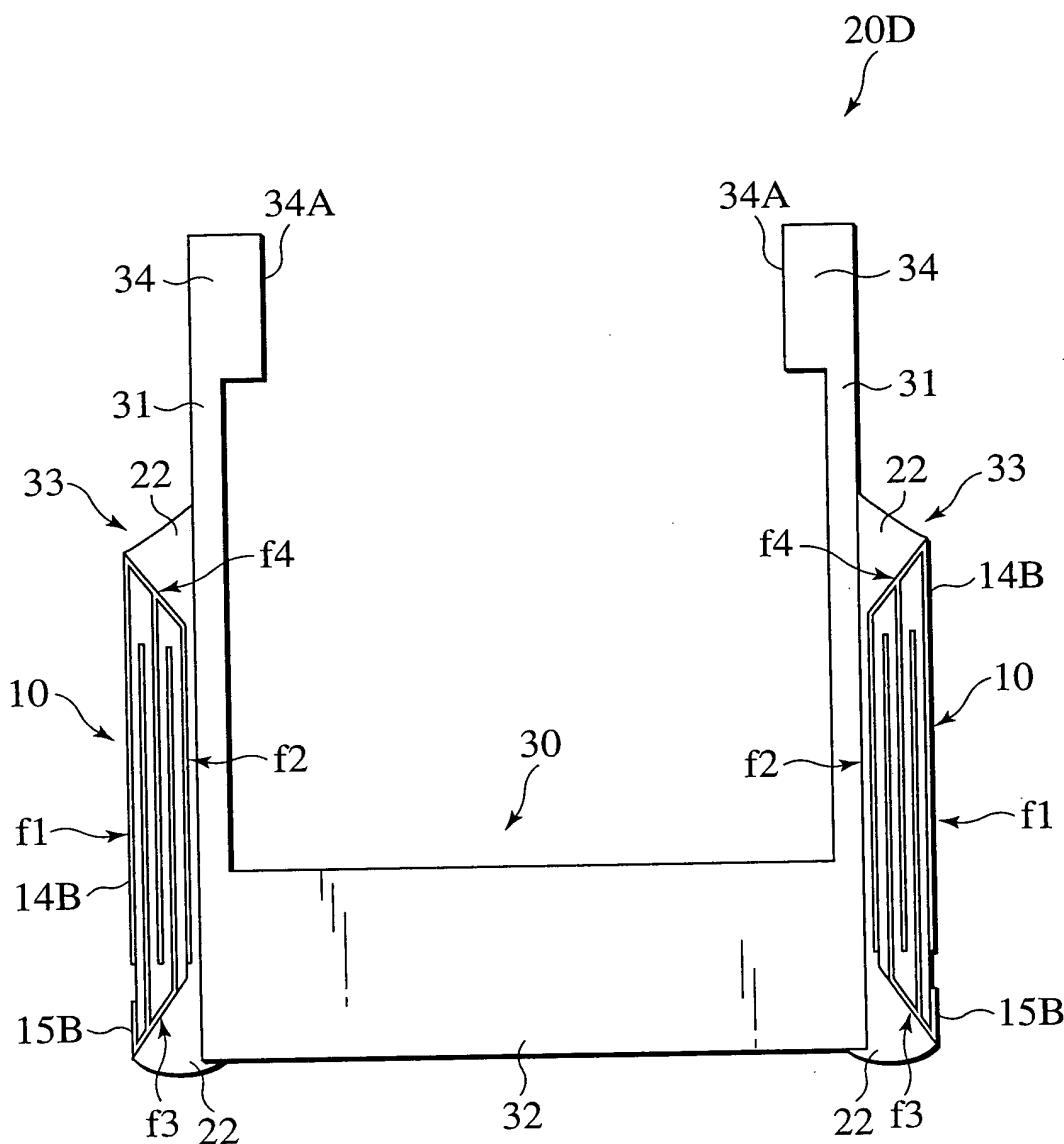
FIG.10



Applicant(s): Masahiko NAMERIKAWA, Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
Our Docket No.: 815_001

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FIG. 11



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FIG.12

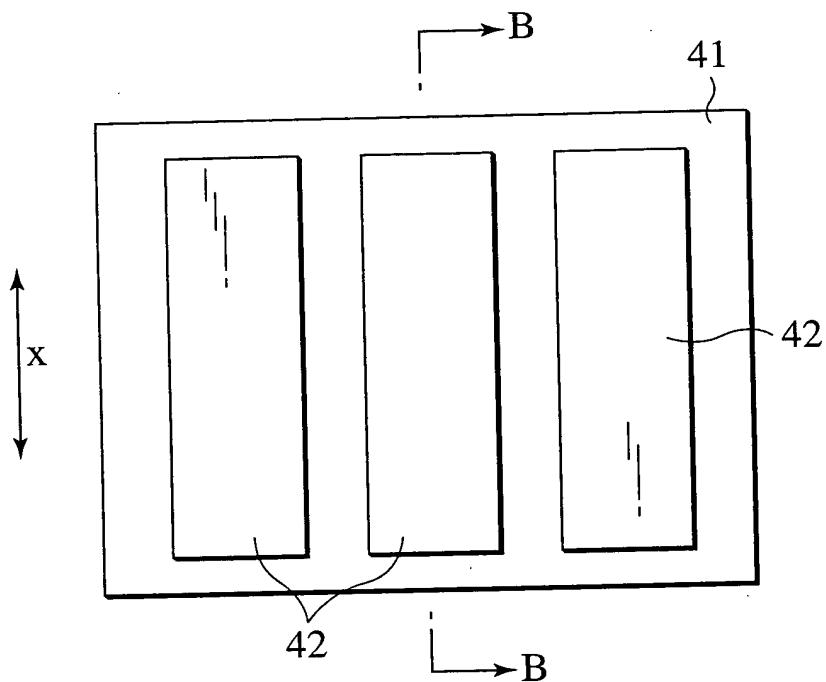
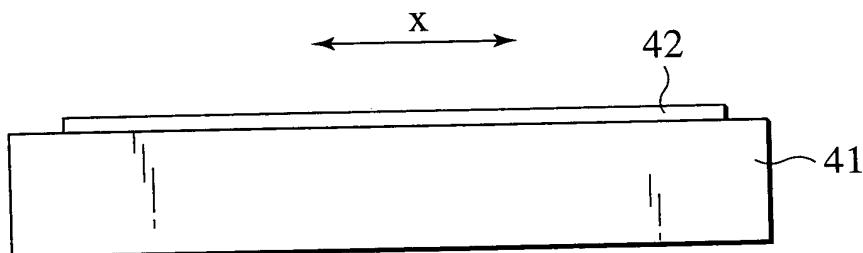


FIG.13

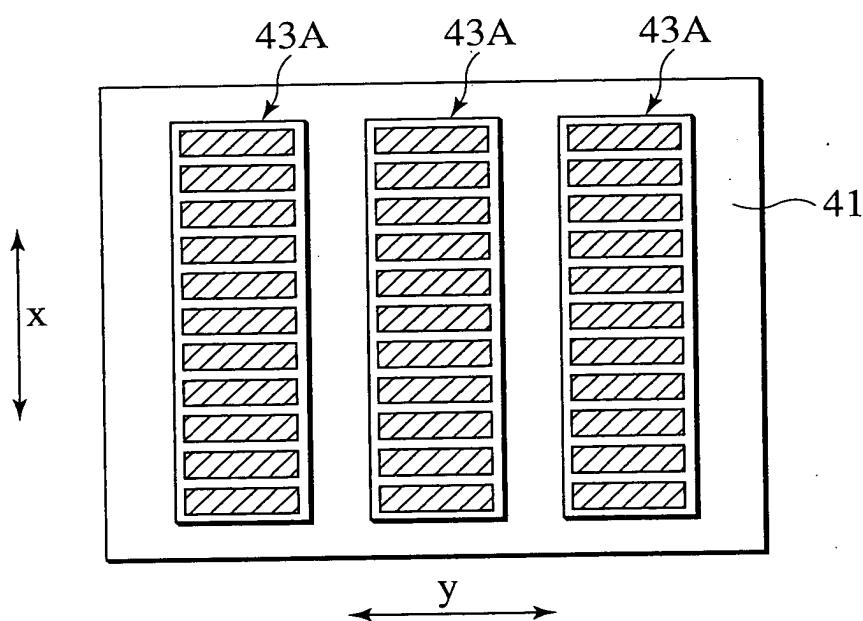


Applicant(s): Maki NAMERIKAWA, Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
Our Docket No.: 815_001

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FIG.14

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FIG.15

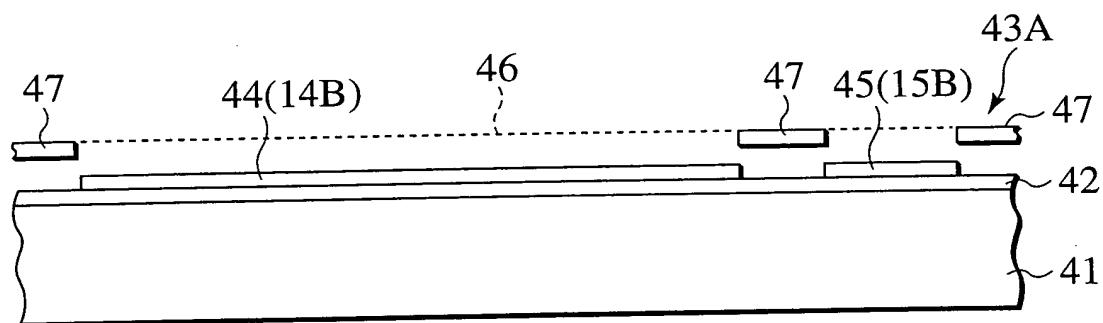
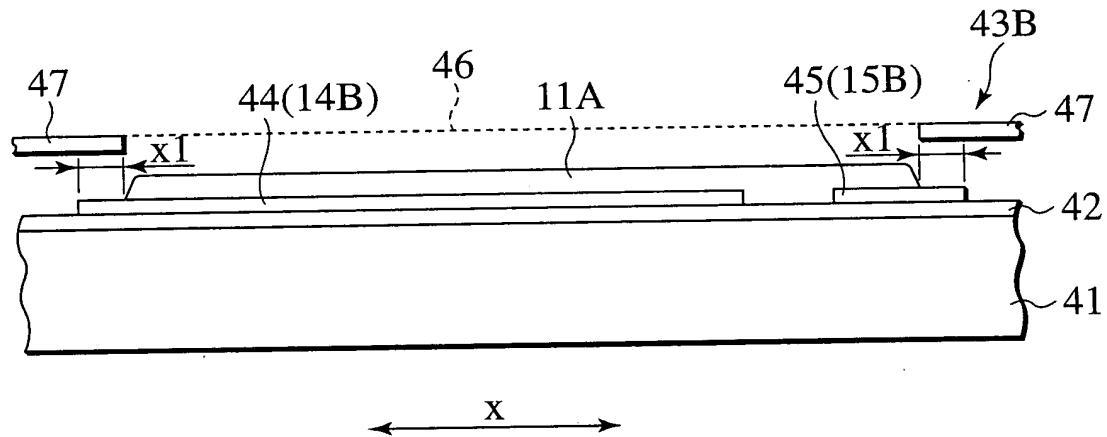


FIG.16



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FIG.17

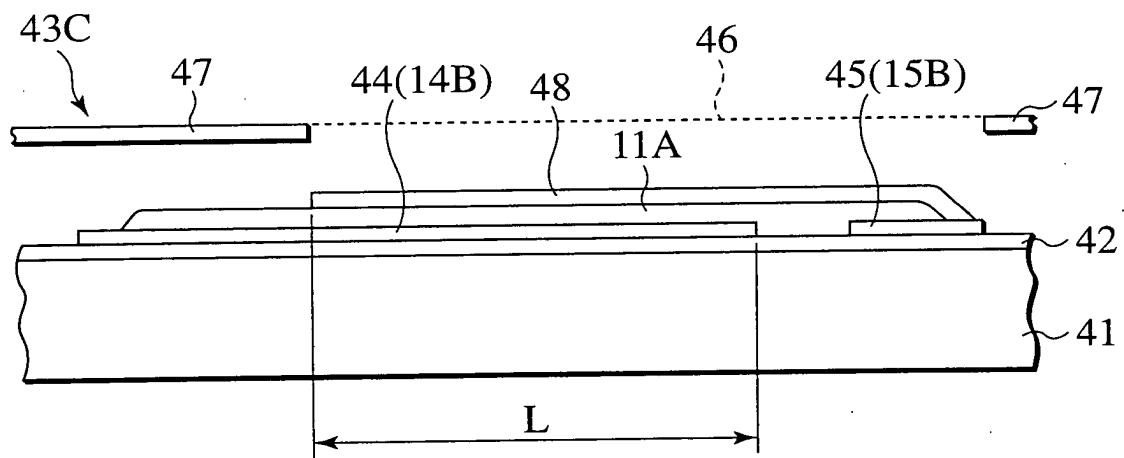
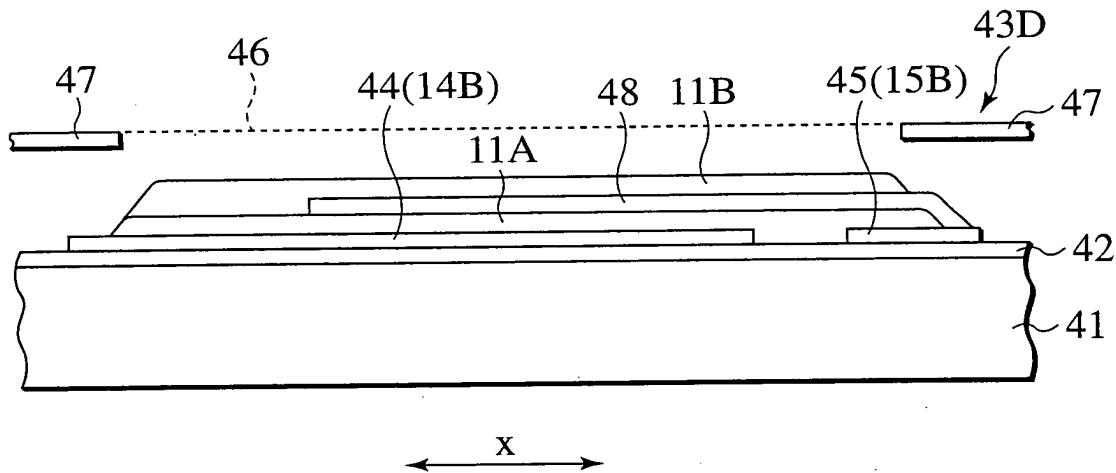


FIG.18



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FIG.19

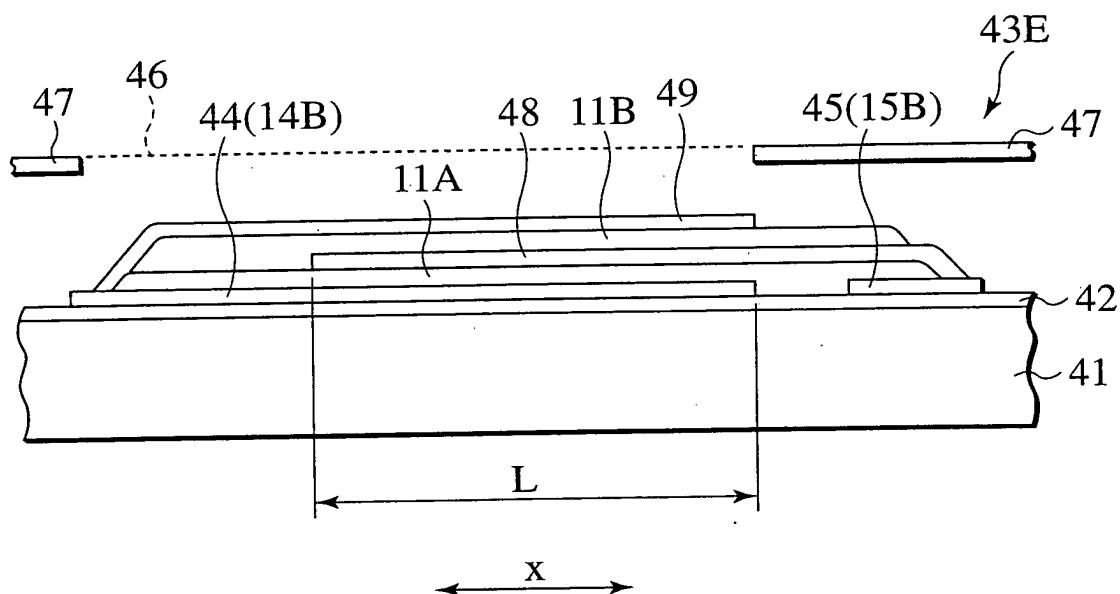
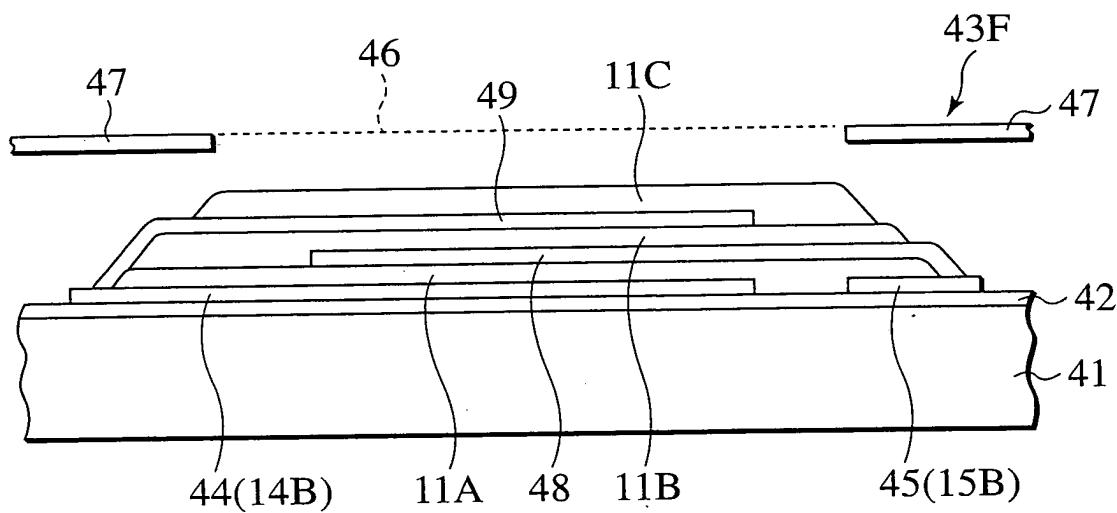


FIG.20



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FIG.21

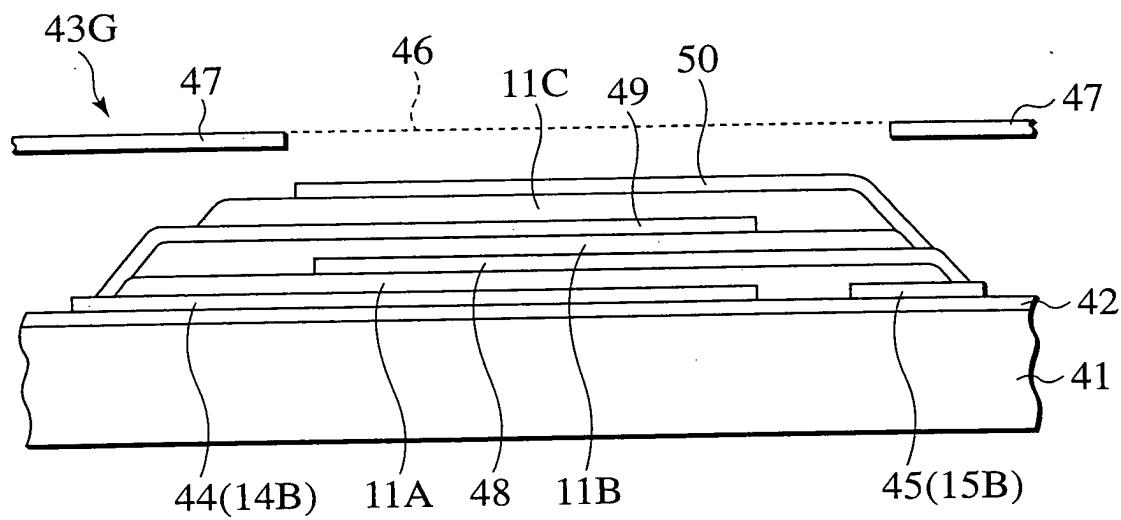
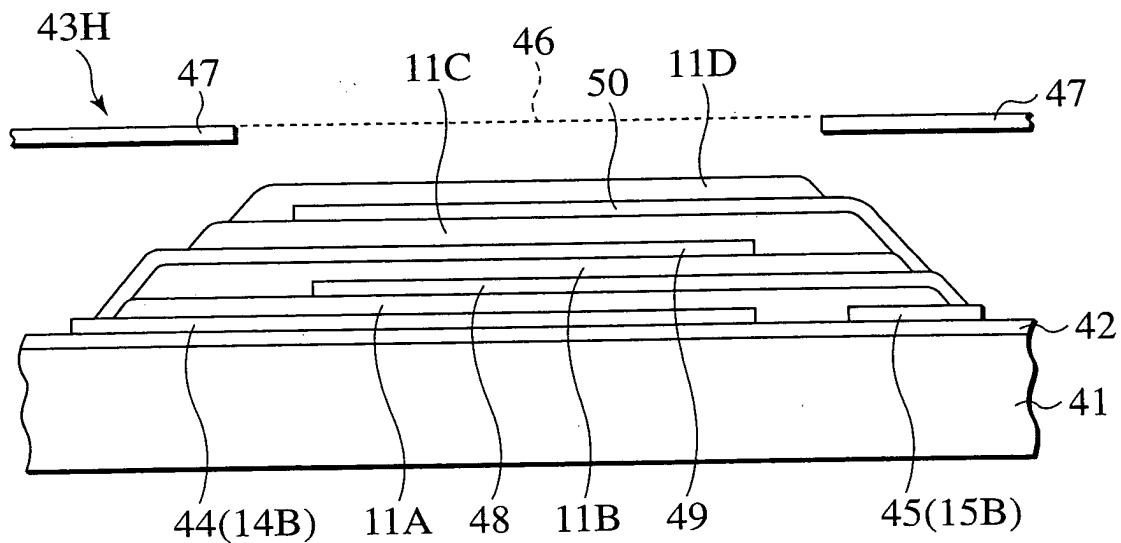


FIG.22



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FIG.23

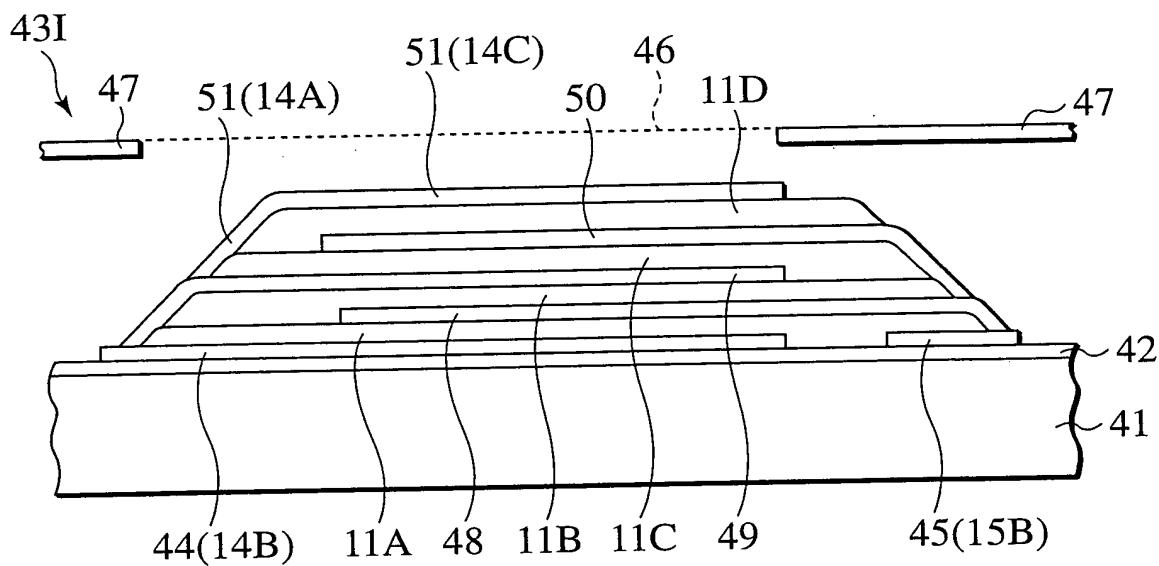
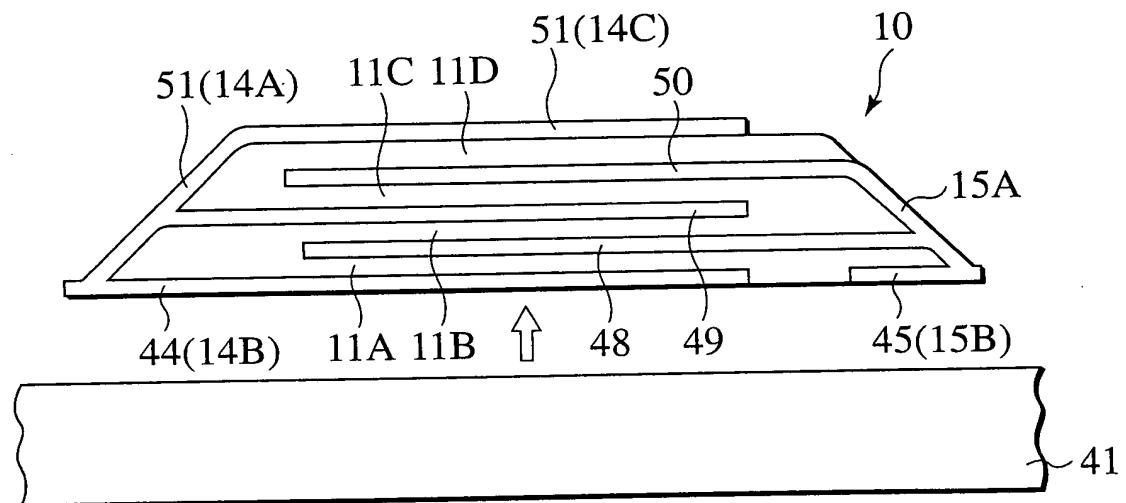


FIG.24



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FIG.25

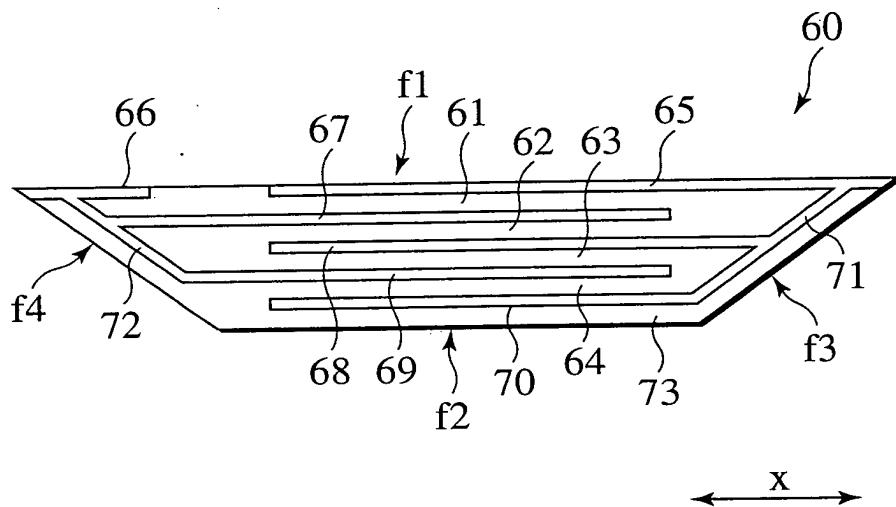
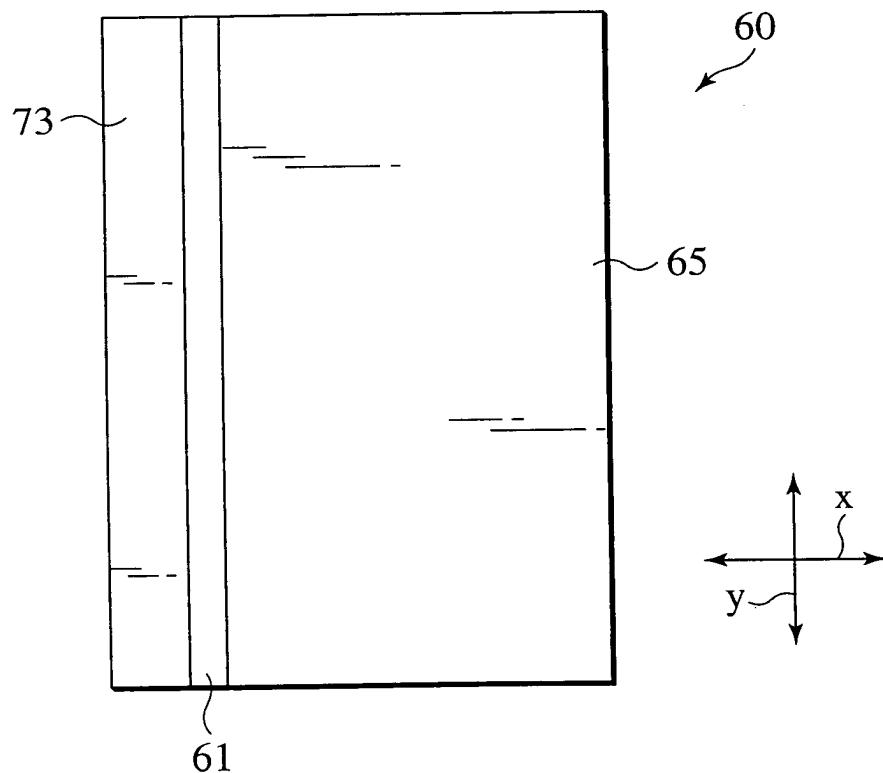


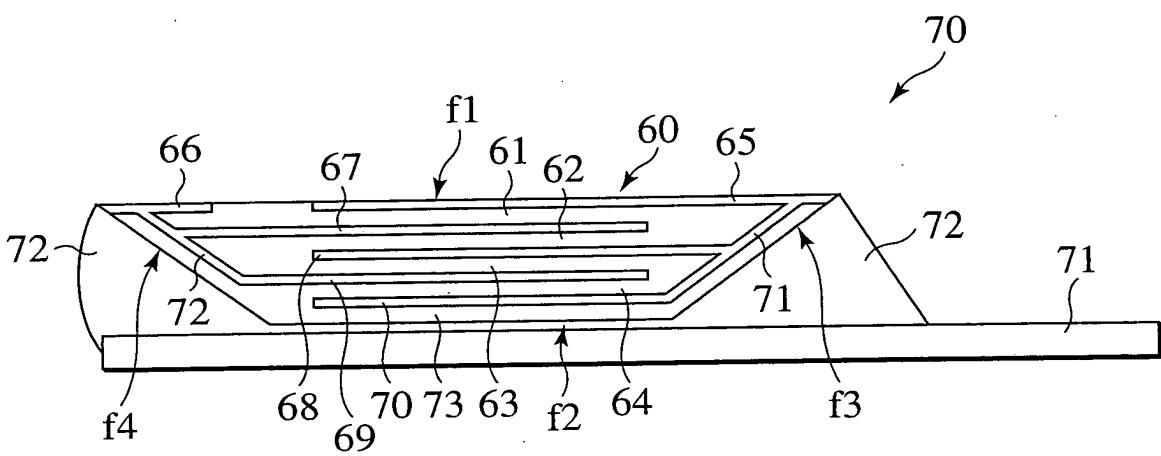
FIG.26



Applicant(s): Masahiro NAMERIKAWA, Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
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FIG.27



Applicant(s): Mochiko NAMERIKAWA; Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
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FIG.28

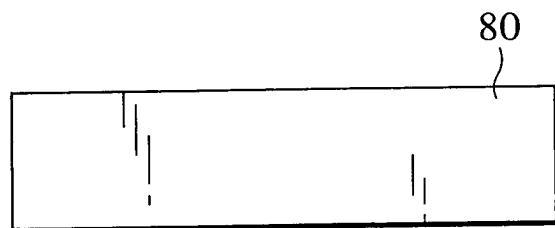
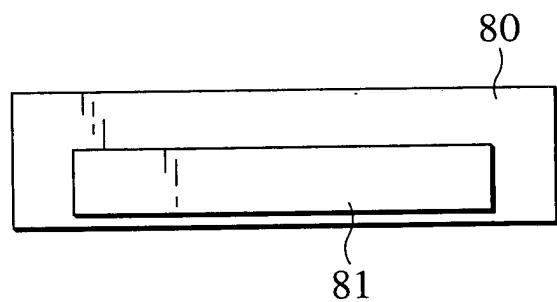


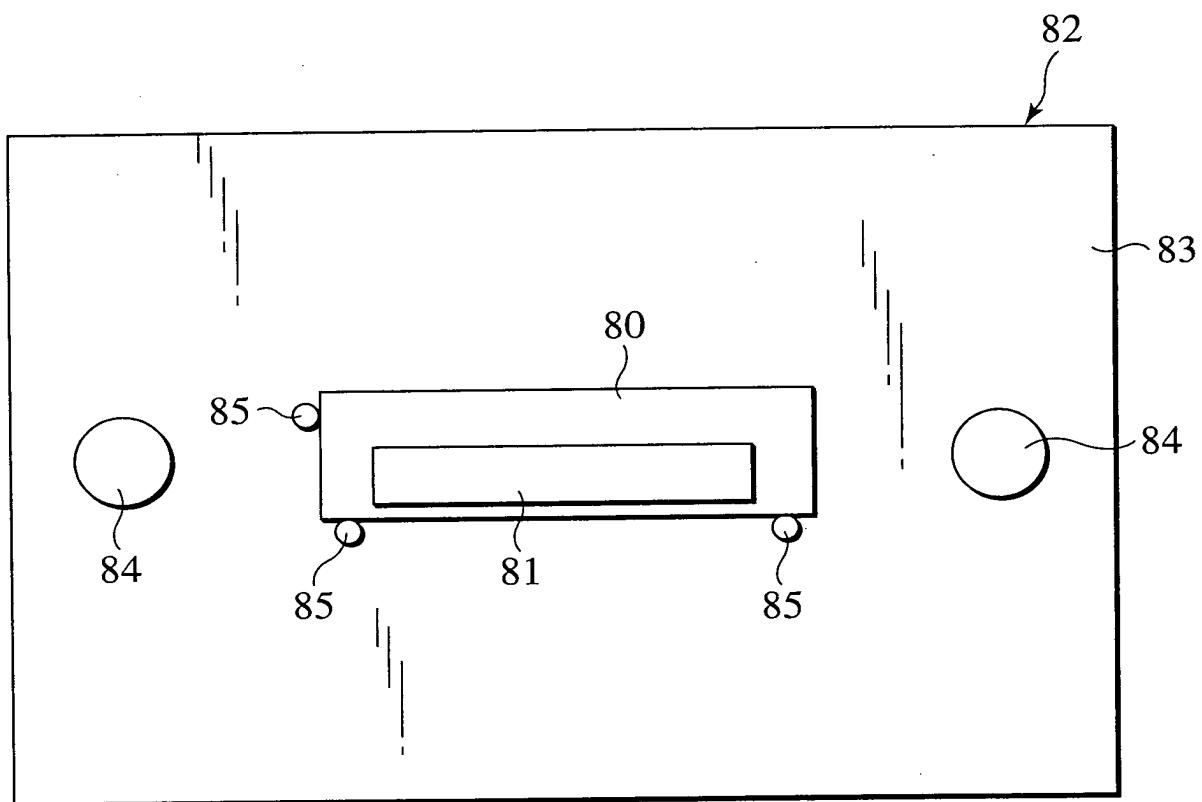
FIG. 29



Applicant(s): Masahiko NAMERIKAWA; Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
Our Docket No.: 815_001

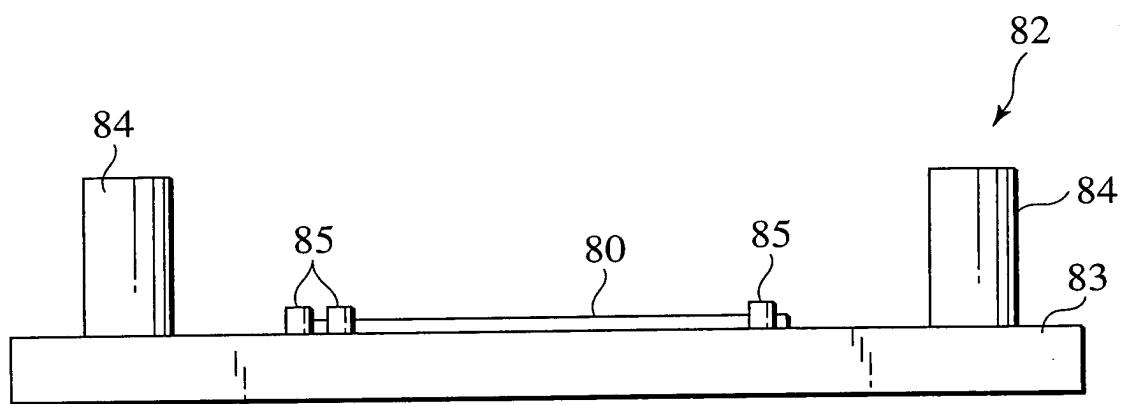
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FIG.30



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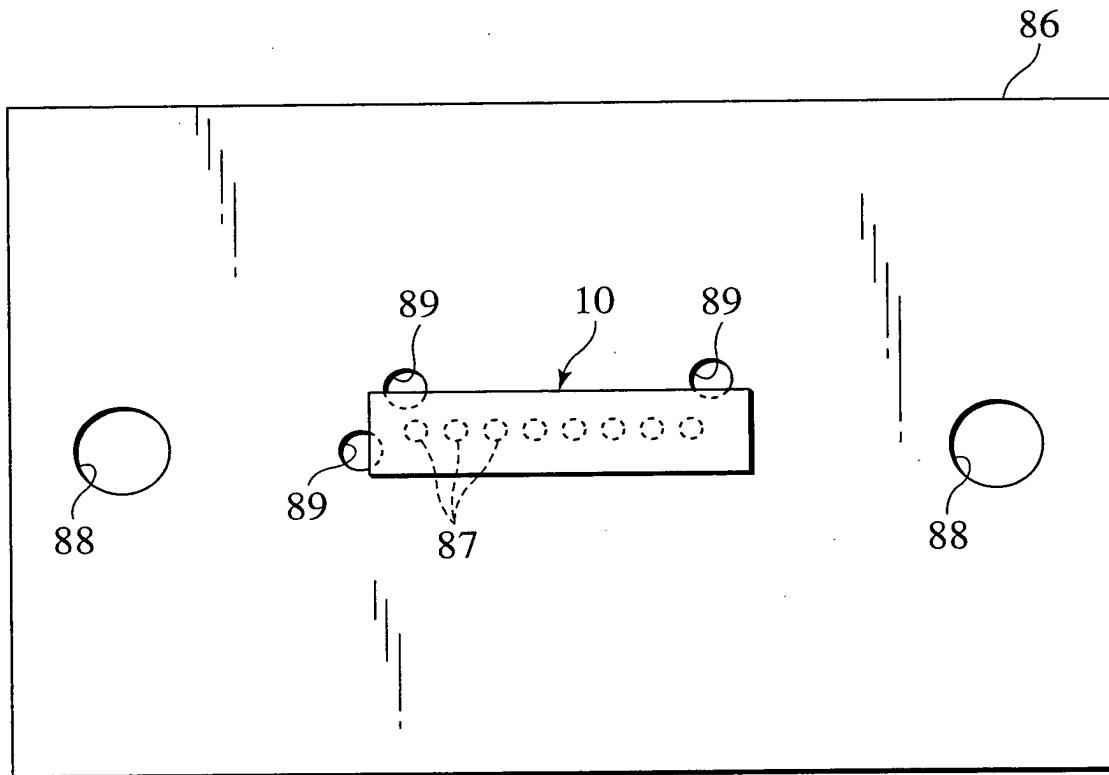
FIG.31



Applicant(s): Masahiko NAMERIKAWA, Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: HIGH DIELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCT, METHOD THEREOF
Our Docket No.: 815_001

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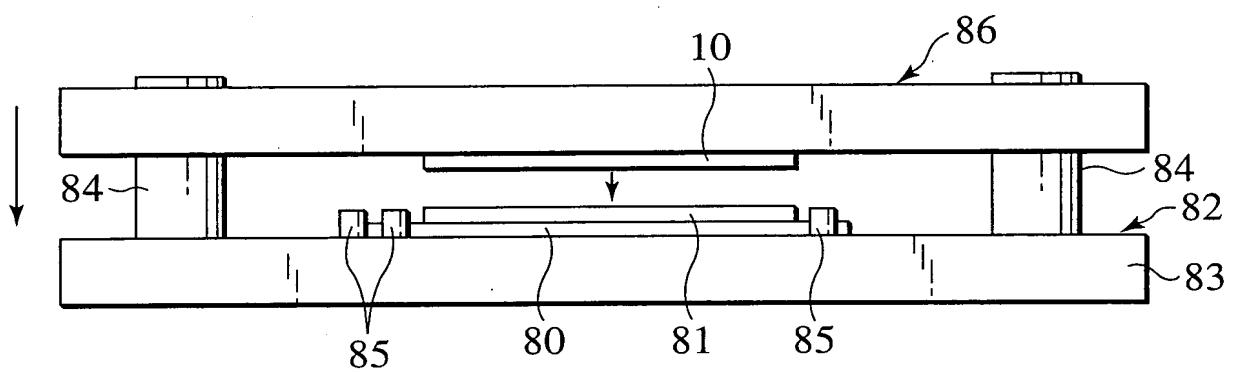
FIG.32



Applicant(s): Masahiko NAMERIKAWA, Kazuyoshi SHIBATA and Masaki IWAMOTO
Title: PIEZOELECTRIC/ELECTROSTRRICTIVE ELEMENT AND
PIEZOELECTRIC/ELECTROSTRRICTIVE DEVICE AND PRODUCTION METHOD THEREOF
Our Docket No.: 815_001

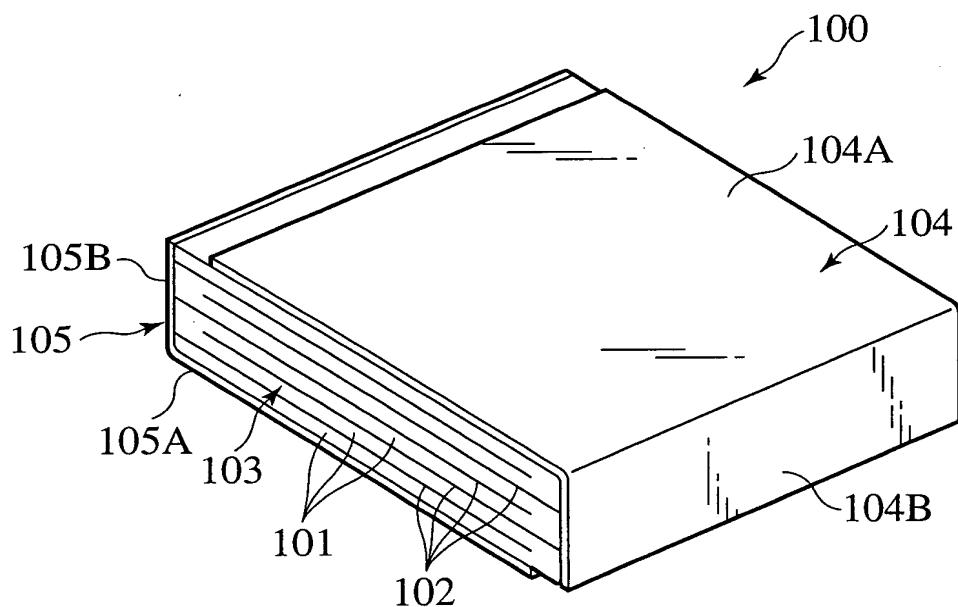
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FIG.33



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FIG.34



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FIG.35

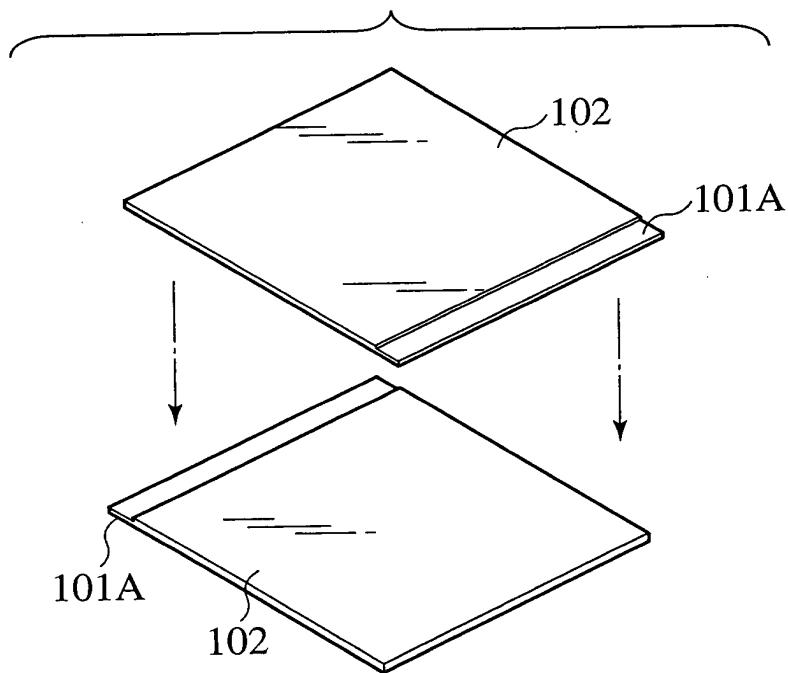
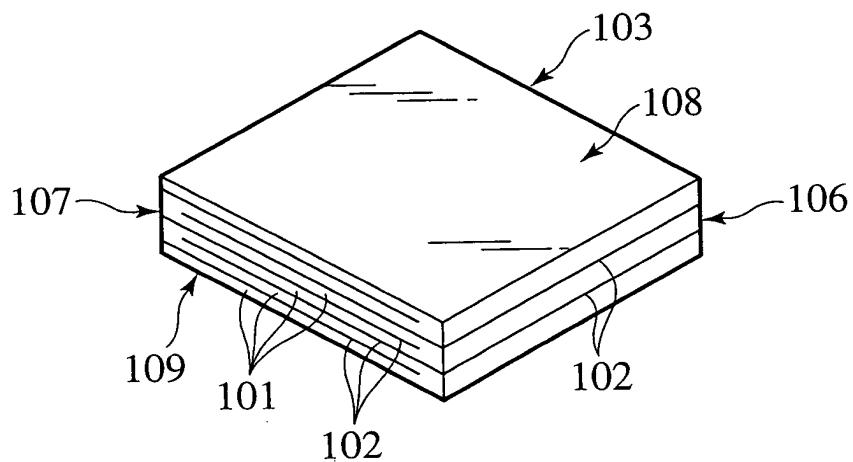


FIG.36



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FIG.37

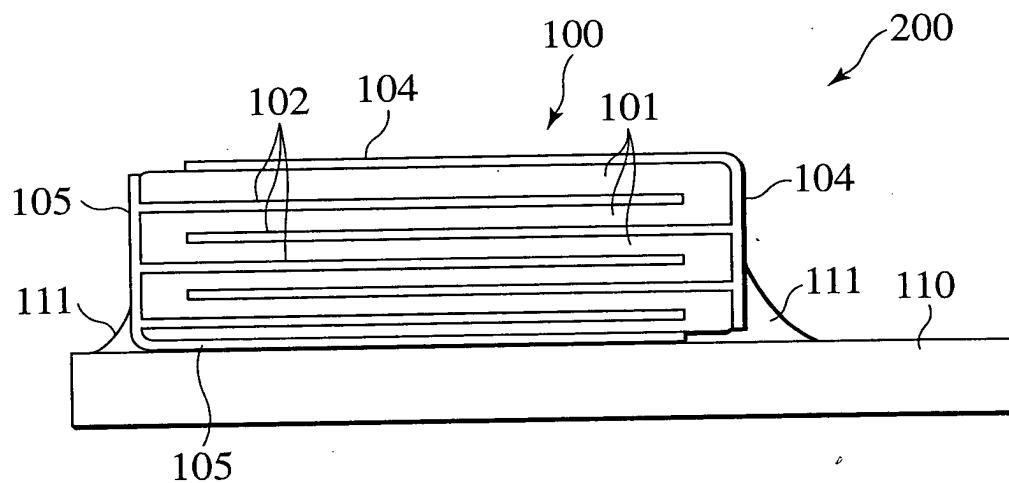
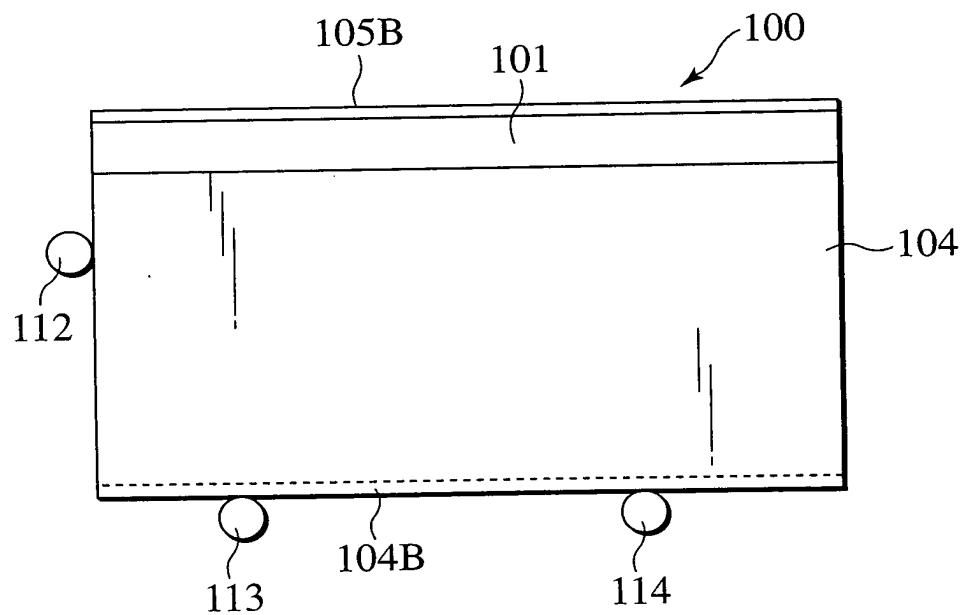


FIG.38



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FIG.39

